



PATENT

Attorney Docket No.: 16869P-017810US  
Client Ref. No.: 210000889US2

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Takashi Hiroi et al.

Application No.: 09/802,693

Filed: March 8, 2001

For: A CIRCUIT PATTERN  
INSPECTION METHOD AND  
APPARATUS

Customer No.: 20350

Confirmation No. 8024

Examiner: Brian P. Werner

Technology Center/Art Unit: 2621

COMMUNICATION AFTER  
ALLOWANCE UNDER 37 CFR § 1.312(a)

**Mail Stop Issue Fee**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowance mailed June 29, 2005, please consider the following remarks.